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APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	TOT CLAIMS	IND CLAIMS
10/590,122	08/18/2006	1639	1460	2352.016	13	4

CONFIRMATION NO. 9927

CORRECTED FILING RECEIPT

23405  
HESLIN ROTHENBERG FARLEY & MESITI PC  
5 COLUMBIA CIRCLE  
ALBANY, NY 12203



Date Mailed: 07/29/2008

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please submit a written request for a Filing Receipt Correction. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections**

**Applicant(s)**

Naomi Yamakawa, Saitama, JAPAN;

**Assignment For Published Patent Application**

Japan Science and Technology Center (Kawaguchi-shi) JAPAN

Tokyo Metropolitan Foundation for Research on Aging & Promotion of Human Welfare, Tokyo, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number 23405

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP2005/002490 02/17/2005

**Foreign Applications**

JAPAN 2004-044759 02/20/2004

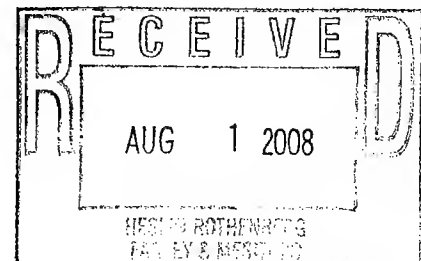
**If Required, Foreign Filing License Granted:** 06/06/2008

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US 10/590,122**

**Projected Publication Date:** 09/18/2008

**Non-Publication Request:** No

**Early Publication Request:** No



**Title**

Dna Array for Analyzing Dna Methylation, Method of Producing the Same and Method of Analyzing Dna Methylation

**Preliminary Class**

506

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Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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Via EFS Web

Deposit Date: August 8, 2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: YAMAKAWA, Naomi Attorney Docket No.: 2352.016  
Serial No.: 10/590,122 Group Art Unit: 1632  
Filed: August 18, 2006 Examiner: Unknown  
Title: DNA ARRAY FOR ANALYZING DNA METHYLATION, METHOD OF  
PRODUCING THE SAME AND METHOD OF ANALYZING DNA  
METHYLATION

To: Commissioner for Patents  
Office of Initial Patent Examination's Filing Receipt Corrections  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR CORRECTED FILING RECEIPT**

Applicants attach herewith a copy of the Official Filing Receipt relative to the above-identified patent application.

Under the section entitled **Assignment for Published Patent Application**, the first Assignee: Japan Science and Technology Center, Kawaguchi-shi, JAPAN is incorrect. We have circled the errors. Please replace the first Assignee on the Filing Receipt with the correct name and address: Japan Science and Technology Agency, Saitama, JAPAN.

If you have any questions, please contact applicants' undersigned attorney.

Respectfully submitted,



Kathy Smith Dias  
Attorney for Applicants  
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Dated: August 8, 2008  
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